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PATENT  
ATTORNEY DOCKET NO.: 049128-5144

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Byung Chul AHN, et al.	)	Confirmation No.: 8591
	)	
Application No.: 10/774,701	)	Group Art Unit: 2879
	)	
Filed: February 10, 2004	)	Examiner: Patel, V.
	)	
For: METHOD OF PATTERNING	)	
TRANSPARENT CONDUCTIVE FILM,	)	
THIN FILM TRANSISTOR SUBSTRATE	)	
USING THE SAME AND	)	
FABRICATING METHOD THEREOF	)	

Commissioner for Patents  
Customer Window  
Alexandria, VA 22314

Sir:

**SECOND INFORMATION**  
**DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the attached document. To the best of the undersigned's knowledge, this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application, and no fees are believed to be necessary.

The listed document was cited in a Korean Office Action dated January 13, 2006. A copy of the Korean Office Action along with the listed document is attached.

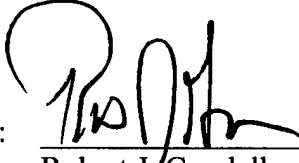
This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed document is material or constitutes "Prior Art." If it should be determined that the listed document does not constitute "Prior Art" under

United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of the document.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application. If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 50-0310.

Respectfully submitted,

**MORGAN, LEWIS & BOCKIUS LLP**

By:   
Robert J. Goodell  
Registration No. 41,040

Dated: February 27, 2006

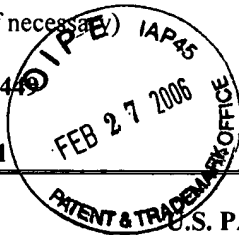
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**INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)

PTO Form 1449

Page 1 of 1


 Attorney Docket No. :  
049128-5144

Application No.: 10/744,701

Applicants: Byung Chul AHN, et al.

Filing Date: February 10, 2004

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**U.S. PATENT DOCUMENTS**

*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date

**FOREIGN PATENT DOCUMENTS**

Document Number	Date	Country	Class	Sub Class	<u>Translation</u> YES NO	
10-2001-0066262 A	July 11, 2001	Korea			Abstract	

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.